

IN THE CLAIMS:

1. – 4. (Cancelled)

5. (Currently Amended) A method for manufacturing plasma display panels (PDPs) comprising:

forming a film of MgO on a substrate in an evaporating room, the substrate being held by one of a plurality of substrate holders, the substrate holders comprising a plurality of elements, and

repeatedly using the plurality of substrate holders, such that when the MgO film is formed on a substrate, at least one substrate holder in the evaporating room is coated with MgO film from forming the MgO film on the substrate, and at least one holder in the evaporating room comprises elements not coated with said MgO film.

6. (Cancelled)